

Notice of References Cited	Application/Control No. 09/615,999	Applicant(s)/Patent Under Reexamination ZHANG ET AL.	
	Examiner Brian K Talbot	Art Unit 1762	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5728214 A	03-1998	Konishi et al.	117/94
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Koster et al., Influence of the surface treatment on the homoepitaxial growth of SrTiO ₃ Material Science & Engineering, vol. B56 pp.209-212 1998.
*	V	Tanaka et al., "Improvement of YBa ₂ Cu ₃ O _x Single-Crystal Surface by Chemical Etching, Japan Journal Applied Physics, vol. 3 pp. L731-L733, 1999
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.